PATENT ASSIGNMENT

Electronic Version v1.1 Stylesheet Version v1.1

SUBMISSION TYPE:	NEW ASSIGNMENT
NATURE OF CONVEYANCE:	ASSIGNMENT

CONVEYING PARTY DATA

Name	Execution Date
Shigeki Katogi	10/26/2007
Hiroyuki Izawa	10/26/2007
Houko Sutou	11/01/2007
Masami Yusa	11/07/2007
Tohru Fujinawa	11/12/2007

RECEIVING PARTY DATA

Name:	Hitachi Chemical Company, Ltd.	
Street Address:	1-1, Nishi-Shinjuku 2-chome, Shinjuku-ku	
City:	Tokyo	
State/Country:	JAPAN	
Postal Code:	163-0449	

PROPERTY NUMBERS Total: 1

Property Type	Number	
Application Number:	11908897	

CORRESPONDENCE DATA

Fax Number: (703)979-7429

Correspondence will be sent via US Mail when the fax attempt is unsuccessful.

703-979-5700 Phone: Email: gands@szipl.com Correspondent Name: Griffin & Szipl, P.C. Address Line 1: 2300 9th Street South

Address Line 2: Suite PH-1

Address Line 4: Arlington, VIRGINIA 22204

ATTORNEY DOCKET NUMBER: SOEI0027 NAME OF SUBMITTER: Bridget D. Burke

PATENT 500906609 REEL: 022935 FRAME: 0524

Total Attachments: 2 source=09-07-09 Assignment#page1.tif source=09-07-09 Assignment#page2.tif

> PATENT REEL: 022935 FRAME: 0525

ASSIGNMENT

Whereas	s, I/we,					
N	ame	Address	;			
_			=	I COMPANY LTD		
1) Shigeki KA	TOGI	c/o Electronic Materials R&D Center, HITACHI CHEMICAL COMPANY, LTD., 48, Wadai, Tsukuba-shi, Ibaraki 300-4247 Japan				
		c/o Electronic Materials R&D Cente		I COMPANY LTD		
2) Himmanis 17	A 18/A		I, I II I AOI II OI IEIWIOA	L COMPANT, LTD.,		
2) Hiroyuki IZ	AVVA	48, Wadai, Tsukuba-shi, Ibaraki 300-424	7 Japan			
 		c/o Advanced Materials R&D Cente		I COMPANY LTD		
0) HI OUT	011		I, THEADIN CHEMICA	L COMPANT, LTD.,		
3) Houko SUT	00	13-1, Higashi-cho 4-chome, Hitachi-shi, Ibaraki 317-8555	lanan			
		c/o Electronic Materials R&D Center		COMPANY LTD		
4) 11	•	GO Electronic Materials N&D Center	, HITAUHI UHEIVIIUAI	L COMPANT, LTD.,		
4) Masami YU	SA	48, Wadai,	7 1			
		Tsukuba-shi, Ibaraki 300-424 c/o Goshomiya Works, HITACHI CH		LTD		
		WO GOSHOIIIIYA WORKS, HITACHI CH	EMICAL COMPANY,	L (D.,		
5) Tohru FUJI	NAWA	1150, Goshomiya,	4			
	· · · · · · · · · · · · · · · · · · ·	Chikusei-shi, Ibaraki 308-852	+ Јарап			
hereinafter calle	d assignor(s), have	invented certain improvement	ts in			
		JIT CONNECTING MATERIA		N STRUCTURE OF CIT	CHIT MEMBER	
AND SEMICON	DUCTOR DEVICE	TO CHILD IN CHAILER	L, COMMECTIO	IN OTROOTERE OF CIT	COIT WEINBER,	
and avected a	a amaliantina fan Latt.	and Data of afther Heller and Out	F.A			
otherwise indica		ers Patent of the United State	s of America the	erefor on even date here	with unless	
otherwise indica				4.4.00000		
140		eptember 17, 2007 s	Serial No	11/908897	; and	
Whereas						
HITACH	CHEMICAL COMP.					
	1-1, Nishi-Shinjuku Shinjuku-ku, Tokyo					
	-	•				
(assignee), desi	res to acquire the en	ntire right, title and interest in	the application a	nd invention, and to any	United States	
patents to be ob	-			_		
NOW THE	=REFORE, be it know	wn that, for good and valuable	e consideration t	from assignee, the rece	ipt of which is	
transfer and col	eagea, i/vv=, as assi	ignor(s), have sold, assigned,	transferred, and	d set over, and do hereb	y sell, assign,	
this invention an	d this application, ar	nee, its lawful successors and nd all divisions, and continuat	i assigns, MY/O	UR entire right, title, and	interest in and to	
which may be gr	anted thereon, and	all reissues thereof; and I/WE	herehv authoriz	e and request the Com	e United States	
Patents and Tra	demarks of the Unite	ed States to issue all Letters F	Patent for this in	rention to assignee, its	Successors and	
assigns, in acco	rdance with the term	is of this Assignment;				
VAID IVVI	E LIEDERV further of	overent and agree that IAME				
assignee its sur	cessors and assign	ovenant and agree that I/WEs, any facts known to ME/US	will, without funt respecting this is	ner consideration, comm	iunicate with	
proceeding, sign	all lawful papers wh	nen called upon to do so, exec	cute and deliver	all naners that may be i	ny legal necessary or	
desirable to perf	ect the title to this in	vention in said assignee, its s	uccessors and a	assigns, execute all divi	sional.	
continuation, and	d reissue application	is, make all rightful oaths and	generally do eve	erything possible to aid	assignee, its	
successors and	assigns, to obtain ar	nd enforce proper patent prote		contion in the United Cta		
	anv expense inciden	at to the execution of such no	ection for this inv	remitor in the Office Sta	ites, it being	
assigns.		it to the execution of such pap	ection for this inv pers shall be bor	ne by the assignee, its	ites, it being successors and	
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1):	INVENTORS	it to the execution of such par	ection for this invocers shall be bor	ne by the assignee, its	successors and	
		, La Josa	ection for this invocers shall be bor	ne by the assignee, its	successors and	
Name:		Shigeki KATOG	ection for this invocers shall be bor	ne by the assignee, its	successors and	
		Shigeki KATOGY	ection for this invocers shall be bor	DATE SIGN	successors and	
2):		Shigeki KATOGY	ection for this invoicers shall be bor	ne by the assignee, its	successors and	
Name: 2): Name:		Shigeki KATOGI Legura Hiroyuki IZAWA	ection for this invocers shall be bor	DATE SIGN	successors and	
2):		Shigeki KATOGY	ection for this invocers shall be bor	DATE SIGN	successors and	

(Legalization not required for recording but is prima facie evidence of execution under 35 U.S.C. § 261)

Name:

4): Name: 5): Name: John Flymawa Tohru FUJINAWA

Nov. 12. 2007

(Legalization not required for recording but is prima facie evidence of execution under 35 U.S.C. § 261)